

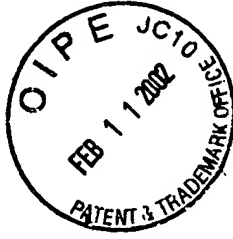
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

# 23/Respon:  
2/21/02  
V. Vannae

In re the Application of:

SASHIDA et al.

Serial Number: 09/321,605



Group Art Unit: 2813

Filed: May 28, 1999

Examiner: J. Chen

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING  
CAPACITOR

RESPONSE TO EXAMINER INTERVIEW

Commissioner for Patents  
Washington, D.C. 20231

February 11, 2002

Sir:

This is in response to the Examiner interview of December 18, 200 and the Office Action dated September 11, 2001. Reconsideration of the claims and allowance of the application are respectfully requested in light of the following remarks.